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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Ye, et al.

Serial No.: 10/078,720

Filed: February 19, 2002

For: **Method and Apparatus for Cutting a Substrate Using Laser Irradiation**

Attorney's Docket No. 4795-002

Elve, Maria Alexandra
Examiner
Group Art Unit: 1725

Raleigh, North Carolina

October 10, 2003

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

10, 2003
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RESPONSE TO NON-FINAL OFFICE ACTION MAILED JULY 11, 2003

Dear Sir:

Applicants submit the following response in reply to the Office Action mailed on the above date. The Commissioner is hereby authorized to charge any fees or charges due in association with this response to Deposit Account 18-1167.